

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/783,419
Confirmation No. 6384
Filing Date February 19, 2004
Inventor Yoshiki Hishiro
Assignee Micron Technology, Inc.
Group Art Unit 2814
Examiner Gnette Peralta
Attorney Docket No. MI22-2507
Title: Methods of Forming Semiconductor Constructions

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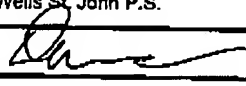
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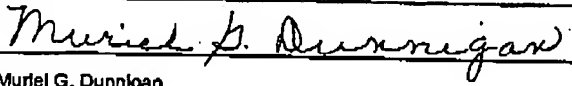
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	Filing Date	February 19, 2004
	First Named Inventor	Yoshiki Hishiro
	Art Unit	2814
	Examiner Name	Ginette Paraita
	Attorney Docket Number	MI22-2507
Total Number of Pages in This Submission		11

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RESPONSE TO JULY 14, 2004 OFFICE ACTION

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